

<b>Notice of References Cited</b>	Application/Control No. 10/590,663	Applicant(s)/Patent Under Reexamination KOBAYASHI, HIDEO	
	Examiner Sylvia R. MacArthur	Art Unit 1716	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,332,055	02-2008	Orii et al.	156/345.17
*	B	US-6,793,769	09-2004	Kajino et al.	156/345.55
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	D	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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